

#6

LIST OF PUBLICATIONS CITED BY APPLICANT			<u>Attorney Docket No.</u> SEL 191		<u>Serial No.</u> Not Assigned	
			<u>Applicant</u> Koichiro TANAKA et al		09/610637	
			<u>Filing Date</u> Herewith 7/5/00		<u>Group</u> 2813	

JCS42 U.S. PTO
09/610637

U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	5,561,081	10/01/96	Takenouchi et al	437	174	02/03/94
	5,897,799	04/27/99	Yamazaki et al	219	121	06/11/96
	5,900,980	05/04/99	Yamazaki et al	359	619	02/06/97
	5,959,779	09/28/99	Yamazaki et al	359	624	03/04/98
	5,968,383	10/19/99	Yamazaki et al	219	121	10/23/97
	6,002,101	12/14/99	Yamazaki et al	219	121	10/23/97
	6,002,523	12/14/99	Tanaka	359	624	09/29/98
	6,038,075	03/14/00	Yamazaki et al	359	626	02/28/97
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	JP 11-097702	04/09/99	Semiconductor Energy Laboratory Co., Ltd.	—	—	09/19/97
	JP 11-133463	05/21/99	Semiconductor Energy Laboratory Co., Ltd.	—	—	10/31/97
OTHER PUBLICATIONS (Including Author, Title, Date, Pertinent Pages)						
	English abstract re Japanese Patent Application No. JP 11-097702, published April 9, 1999. English abstract re Japanese Patent Application No. JP 11-133463, published May 21, 1999.					
EXAMINER:				DATE CONSIDERED: 7/25/03		
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.						